Form PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

Docket Number (Optional) 4373.2US (00-0036.02/US)	Application Number Not Yet Assigned			
Applicant Chopra et al.				
Filing Date July 14, 2003	Group Art Unit Unknown			

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	Sheet 2 of 2
Docket Number (Optional) 4373.2US (00-0036.02/US)	Application Number Not Yet Assigned
Applicant Chopra et al.	
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INFO	RMATION	DI	SCLOSURE	Application Number	10/620,002	
STATEMENT BY APPLICANT				Filing Date	July 14, 2003	
				First Named Inventor	Chopra et. al.	
				Group Art Unit	3723	
(use as many sheets as necessary)			necessary)	Examiner Name	unknown	
Sheet	1	of	1	Attorney Docket Number	2269-4373.2US (00-0036.02/US)	1

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